

Docket Number: 061063-0315051

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

10/525 442
DT15 PCT/PTO 24 FEB 2005
Client Reference: OSP-17496

In Re the Application of

SO IK BAE, et al.

Group Art Unit:

Application No.:

Examiner:

Filed: February 24, 2005

Confirmation No.:

For: METHOD FOR ELIMINATING BORON CONTAMINATION IN ANNEALED WAFER

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

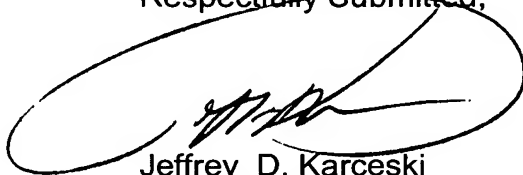
Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. As this application is being filed after June 30, 2003, no copy of the cited U.S. patent application is enclosed. However, one copy of each of the other reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the references have been considered, per MPEP § 609.

This Information Disclosure Statement is being filed with the application. No certification or fee is required.

English-language Abstracts of the non-English language references are attached hereto and are relied upon to provide a statement of relevance for each reference. The International Search Report itself is in the Japanese language and a copy is provided with this submission.

Respectfully Submitted,



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